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APPLICANTS Koichi Terashima, Tokyo, JAPAN; Yoshinao Miura, Tokyo, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/01315 02/09/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-031110 02/07/2003 JAPAN 2003-129878 05/08/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/PAPE A SENE/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 31	TOTAL CLAIMS 65	INDEPENDENT CLAIMS 9
ADDRESS SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES						
TITLE Method for forming nickel silicide film, method for manufacturing semiconductor device, and method for etching nickel silicide						
FILING FEE RECEIVED 4350	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			